INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 6, 2026

IGI Report Number	LG772677536
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	13.55 X 9.78 X 5.96 MM

GRADING RESULTS

Carat Weight	5.01 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	VERY GOOD

ADDITIONAL GRADING INFORMATION

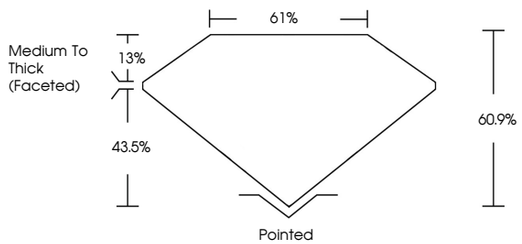
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG772677536

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG772677536

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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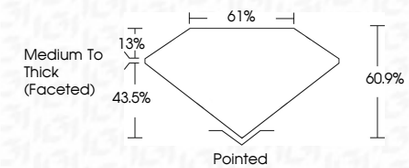

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IGI

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OVAL BRILLIANT
13.55 X 9.78 X 5.96 MM

Carat Weight	5.01 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	VERY GOOD
Depth	60.9%
Table	61%
Girdle	Medium To Thick (Faceted)
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
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